



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

August 19, 2026	
IGI Report Number	LG828662400
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	OVAL BRILLIANT
Measurements	14.74 X 10.43 X 6.30 MM

GRADING RESULTS

Carat Weight	6.08 CARATS
Color Grade	F
Clarity Grade	VVS 2

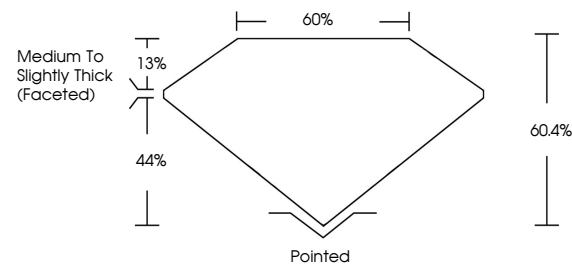
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	131 LG828662400

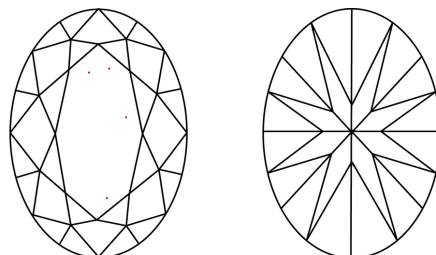
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG828662400
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

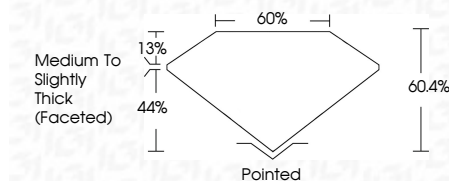
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www.igi.org

August 19, 2026	CV Report No. LG826642000	4.08 CARATS
GYAL BRILLANT		F
14.74 X 10.43 X 4.30 MM		VVS 2
		60.4%
		60%
		Medium to Slightly Thick (Faceted)
		Pointed
		EXCELLENT
		EXCELLENT
		NONE
		ISSN LG826642000

Comments: Gemmy Crystal Diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type IIA